

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Mitsuhiro ICHIJO, et al. ) Group Art Unit: 2814  
Application No. 10/804,053 ) Examiner: Long Pham  
Filed: March 19, 2004 ) Confirmation No. 7738  
For **FILM FORMATION METHOD AND** )  
**MANUFACTURING METHOD OF**  
**SEMICONDUCTOR**

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**AMENDMENT**

As part of a Request for Continued Examination (RCE), as submitted herewith, and further to the Advisory Action mailed **October 25, 2006**, and final Official Action mailed **June 28, 2006**, please amend the above-identified patent application, as follows: